

Application/Control No.	Applicant(s)/Patent under Reexamination
- 10/822,703	IWAHARA ET AL.
Examiner	Art Unit
MICHAEL L. SHIPPEN	1621

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Class	Subclass	Date	Examiner
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
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